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TC 1700

1765  
AF  
Serial No. 10/023,948  
SEC.861  
Amendment dated October 29, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :  
Jae-dong Lee et al. : Group Art Unit 1765  
Serial No. 10/023,948 : Examiner Lynette T. Umez-Eronini  
Filed December 21, 2001 :  
CHEMICAL MECHANICAL POLISHING SLURRY

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**AMENDMENT AFTER FINAL**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop AF  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

In response to the Office Action of August 27, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.